

**Search Notes**

Application/Control No.

10/612,092

Examiner

Arnel C. Lavarias

Applicant(s)/Patent under  
Reexamination

TOGINO, TAKAYOSHI

Art Unit

2872

**SEARCHED**

| Class | Subclass | Date | Examiner |
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**INTERFERENCE SEARCHED**

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**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

|  | DATE      | EXMR |
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| Consulted with Thong Nguyen<br>regarding restriction requirement | 8/30/2005 | ACL  |
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